

**Notice of References Cited**Application No.  
**09/268,948**Applicant(s)  
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**1753**

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**U.S. PATENT DOCUMENTS**

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A					
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**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N						
O						
P						
Q						
R						
S						
T						

**NON-PATENT DOCUMENTS**

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
U	M. Takahashi, et al., "Synthesis of Fe <sub>16</sub> N <sub>2</sub> Films by Using Reactive Plasma", IEEE Tras. on Magn., 29, pp. 3040-3045.	1993
V	A. Kano, et al. "Metastable Fe nitrides with high Bs prepared by reactive sputtering", J. Applied Physics 53 (11), pp. 8332-8334.	11/1982
W		
X		